

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: 10/736,386 )  
Filed: December 15, 2003 ) Conf. No.: 6227  
Title: **METHOD FOR CALCULATING** )  
**HIGH-RESOLUTION WAFER** )  
**PARAMETER PROFILES** )  
Inventors: Bruce Whitefield et al. )  
Art Unit: 2128 )  
Examiner: Kimberly A. Thornwell )  
Atty. Ref: 03-1345 )

**RESPONSE TO THE OFFICE ACTION MAILED FEBRUARY 21, 2008**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application and in response to the Office Action mailed February 21, 2008, kindly enter the following amendments and consider the following remarks toward reconsideration of the present application.